



**Main Activity** 

#### **EQM Cryoharness Integration Report** SPIRE-RAL-REP-002423

Location

**EADS Ottobrunn** 

#### **Reference Documents**

- RD 1 SPIRE FPU Handling and Integration Procedure, SPIRE-RAL-PRC-001923, Issue 4, 08/07/2005.
  RD 2 SPIRE Warm Functional Test Procedures for the CCS, SPIRE-RAL-PRC-002422, Issue 1.4, 15/07/05

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Time UT	Cryoharness Integration Activities	Signature
	Measure bonding of Warm Units to the SVM Simulator according to RD 1, §7.3.6	
	DCU to SVM = 1.53mOhm DPU to SVM = 0.44mOhm FCU to SVM <= 2.9mOhm  Verify correct harness grounding (isolation of FPU Faraday Shield from S/C Chassis) according to RD 1 §7.3.4.2	
	Removed FPU FS bonding lugs from SIH-SS-10 and SIH-SS-11 D-Sub Backshells and isolation >20MOhm Removed FPU FS bonding lugs from SIH-SS-01 and measured isolation. P27, P28, P31 and P32 > 20 MOhm – OK Removed FPU FS bonding lugs from SIH-SS-03 and measured isolation. P29 and P30 Pin, Harness Side = 0.8Ohm <b>Short</b> Socket Harness Side = 0.8Ohm <b>Short</b> Removed FPU FS bonding lugs from SIH-SS-06 and measured isolation. P14, P15 and P16 11.6Ohm Short	
	Disconnected SIH-SS-03 and SIH-SS-06 from SVM-CB Measured isolation of FPU Faraday Shield from S/C Chassis via FPU Connector backshells Discovered intermittent short in SIH-IS-03 and SIH-IS-06 near the SVM-CB Raised NCR (ASED-NC-1246) Tested ground isolation in SIH-SS-01, SIH-SS-03 and SIH-SS-06 when they were disconnected at the SVM-CB and are OK DKG returned to UK while harnesses were re-worked	





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Date 18-Jul-2005
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ime UT	Cryoharness Integratio	n Activities		Signature			
	Did not recheck Warm Unit ground bonding as no work has been carried out on the units						
	Verify correct harness grounding (isolation of FPU Faraday Shield from S/C Chassis) according to RD 1 §7.3.4.2						
	Voling Control Harmond grounding (Icolation of the Charactery Children Holling to No. 1.2.						
	Note: SIH SS 01 and SIL	1 SS 03 were not unmated	from the SVM-CB as the FPU FS bonding I	uge have been correctly			
		1-33-03 Were not unmated	ITOTIL THE SYNI-OB as the FFO FS boliding it	ugs have been confectly			
	implemented						
		_					
	The following isolation wa	as measured					
		Connector	Measurement				
		DCU P14	Isol. >= 20 MOhm				
		DCU P15	Isol. >= 20 MOhm				
		DCU P16	Isol. >= 20 MOhm				
		DCU P27	Isol. >= 20 MOhm				
		DCU P28	Isol. >= 20 MOhm				
		DCU P29	Isol. >= 20 MOhm				
		DCU P30	Isol. >= 20 MOhm				
		DCU P31	Isol. >= 20 MOhm				
		DCU P32	Isol. >= 20 MOhm				
		FCU P11	Isol. >= 20 MOhm				
		FCU P13 FCU P17	Isol. >= 20 MOhm   Isol. >= 20 MOhm				
		FCU P17	Isol. >= 20 MOhm				
		FCU P21	Isol. >= 20 MOhm				
		FCU P23	Isol. >= 20 MOhm				
		FCU P25	Isol. >= 20 MOhm				
		FCU P29	Isol. >= 20 MOhm				
	Successful as oan now r	proposed with the meting of t	he arycharness to EDLL and Warm Units				
	Successiui, so can now p	noceed with the mating of t	he cryoharness to FPU and Warm Units				





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Mated cryoharness to DRCU and FPU/JFS/JFP according to RD 1 §7.3.7.3
Notes: EMI backshells loose when the Jackscrews tightened on the Cold Units. ASED to raise an NCR
DCU J27 and DCU J28 covered with copper tape which needed to be removed prior to integration of harnesses
Step missing from procedure (mating of FPU P19, P21, P23, P25, P27 and P29)
EMI blanking covers for un-used FPU connectors did not mate with MDM connector. Added aluminium tape to the blanking cover to create an EMI gasket. <b>Does this form a trapped volume?</b>
EMI blanking covers not supplied for the JFP P01, P02, P03, P04, P05, P06, P07, P08, P09, P10, P11, P12, P17, P18, P19, P20, P21, P22, P23, P24. Open work RAL to send EADS Copper tape with conductive adhesive. Kapton tape to be applied to MDM connectors to isolate the contacts from the Copper Tape. Copper tape to cover Kapton and form a 360° conductive seal over the connectors. Tape to be pricked to form a vent hole.
JFP L3 strap very close to touching the OBA !
Removed the FPU grounding strap according to RD 1 §7.3.7.3
Mated Mechanism external power supply harness to FCU J20 and stowed outside SVM. Bagged exposed banana plugs in a "lumealloy" bag
Transported DRCU bench power supply into class 100 room and mated J33 and J03 to bench power supply
Switched all DCU external switches to the OFF position.
Booted DPU and then switched on bench power supply
Asier zeroed all bias voltages
Switched all external switches to the ON position
Started WFT





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Date 19-Jul-2005
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Time UT	Cryoharness Integration Activities	Signature
After lunch	Started the covering of the exposed connectors on the JFS by covering the exposed contacts with Kapton and then with Copper Tape	
	Removed EMI covers from HSFPU 121100 J20, J22, J24, J26, J28, J30 and cut a vent notch to remove the potential trapped volume	
	Removed the Alignment Cube (Red tag item)	
	Removed the Aperture Cover (Red tag item)	